

## RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE REQUESTED EXAMINING GROUP 1734

**PATENT** 

Customer No. 22,852 Attorney Docket No. **04329.2677-01** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
Tatsuhiko EMA et al.	) Group Art Unit: 1734
Application No.: 10/736,580	) ) Examiner: Tadesse, Yewebdar T.
Filed: December 17, 2003	) ) ) Confirmation No.: 4483
For: FILM-FORMING METHOD, FILM-FORMING APPARATUS AND LIQUID FILM DRYING APPARATUS	

## **Mail Stop AF**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **AMENDMENT AFTER-FINAL**

In reply to the Office Action mailed September 20, 2005, the period for response to which has been extended to January 20, 2006 by a request for extension of one month and fee payment filed concurrently herewith, and pursuant to 37 C.F.R. § 1.116, Applicants proposes that this application be amended as follows::

Amendments to the Claims are reflected in the listing of claims in this paper beginning on page 2.

Remarks follow the amendment sections of this paper beginning on page 4.